



Femtosecond Light Sources and Their Applications in the Deep UV, Vacuum UV, and Extreme UV

Guest Editor:

Dr. Yuichiro Kida

Japan Synchrotron Radiation
Research Institute, Hyogo 679-
5148, Japan

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Message from the Guest Editor

Dear Colleagues,

This Special Issue, “Femtosecond Light Sources and Their Applications in the Deep UV, Vacuum UV, and Extreme UV” calls for research articles on recent advances in the field of femtosecond light sources in DUV, VUV, and EUV and their applications. The topics include, but are not limited to, recent development on: frequency conversion, light amplification, pulse compression in nonlinear media, lasing and amplification in laser crystals, pulse shaping, seeded and SASE FELs for femtosecond pulses, with unprecedented parameters. The topics also cover ultrafast and nonlinear spectroscopies with advanced femtosecond coherent sources and new findings from them.

Dr. Yuichiro Kida
Guest Editor





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Prof. Dr. Giulio Nicola Cerullo
Dipartimento di Fisica,
Politecnico di Milano, Piazza L.
da Vinci 32, 20133 Milano, Italy

Message from the Editor-in-Chief

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Applied Sciences Editorial Office
MDPI, Grosspeteranlage 5
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